

Notice of References Cited	Application/Control No. 10/524,758	Applicant(s)/Patent Under Reexamination AOYAMA ET AL.	
	Examiner Nathan Bloom	Art Unit 2624	Page 1 of 1

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*	B	US-5,048,102	09-1991	Tararine et al.	382/300
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*	D	US-2003/0020732	01-2003	Jasa et al.	345/645
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NON-PATENT DOCUMENTS

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	U	Nijmeijer et. al., "Correction of Lens-Distortion for Real-Time Image Processing Systems", Proceedings of the 1993 IEEE Workshop on VLSI Signal Processing, Veldhoven, The Netherlands, October 1993, pages 316-324
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.